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18 May 2004  
Date of Deposit

Paul E. Rauch, Ph.D.  
Name of Applicant, Assignee or  
Registered Representative

[Signature]  
Signature

Our File No.: CYP01-002-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: H. Bamnolker et al.

Serial No.: 09/927,863

Filing Date: August 10, 2001

For: METHODS OF FORMING  
SEMICONDUCTOR STRUCTURES HAVING  
REDUCED DEFECTS, AND ARTICLES AND  
DEVICES FORMED THEREBY

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)  
) Examiner: Lynette T. Umez-Eronini  
)  
) Group Art Unit No.: 1765  
)  
)  
)

### TRANSMITTAL

M.S. - AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is:

- ☒ Credit Card Form
- ☒ Two Month Extension of Time (in duplicate)
- ☒ Request for Reconsideration
- ☒ No additional fee is required.
- ☒ The Commissioner is hereby authorized to charge any fees associated with this communication not covered by check or credit card payment or credit any overpayment to Deposit Account No. 50-3123. A duplicate copy of this sheet is attached.

Respectfully submitted,

[Signature]

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